

JUN 01 2006

PATENT  
RESPONSE UNDER 37 C.F.R. 1.116 - EXPEDITED  
PROCEDURE - EXAMINING GROUP 1711

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/706,862 Confirmation No.: 6724  
Applicant(s): Ogihara, et al.  
Filed: November 12, 2003  
Art Unit: 1711  
Examiner: Irina S. Zemel  
Title: COMPOSITION FOR FORMING POROUS FILM, POROUS FILM AND  
METHOD FOR FORMING THE SAME, INTERLEVEL INSULATOR FILM,  
AND SEMICONDUCTOR DEVICE

Docket No.: 035576/271443  
Customer No.: 00826

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

Sir:

In response to the Final Office Action dated May 10, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.

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